

**INFORMATION
DISCLOSURE
STATEMENT**

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Applicant(s): DAVID et al.

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U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Name	Class	SubClass	Filing Date If Appropriate
<i>[Signature]</i>	4,812,344	03/14/89	Jaeger et al.			
<i>[Signature]</i>	5,788,766	08/04/98	Yamamoto et al.			
<i>[Signature]</i>	5,938,679	08/17/99	Freeman et al.			

FOREIGN PATENT DOCUMENTS

	Document Number	Date	Country	Class	SubClass	Translation	
						Yes	No
<i>[Signature]</i>	JP 0 211 4 650	04/26/90	Japan (English Language Abstract Only)				
	JP 0 511 0 163	04/03/93	Japan (English Language Abstract Only)				
	WO 94/21372	09/29/94	PCT				
<i>[Signature]</i>	WO 98/21626	05/22/98	PCT				

OTHER DOCUMENTS (Including Authors, Title, Date, Pertinent Papers, etc.)

<i>[Signature]</i>	C. F. M. Borges, "A Novel Technique for Diamond Film Deposition Using Surface Wave Discharges," <i>Diamond and Related Materials</i> , Vol. 4, pp. 149-154 (1995).
<i>[Signature]</i>	IBM Technical Disclosure Bulletin, "Magnetostrictive Molecule Separator Chromatography," US, IBM Corp., New York, Vol. 37, No. 8, pp. 527-528 (August 1994).

EXAMINER*Alexander***Date Considered***1/10/02*

*Examiner: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.